

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hajime YAMAMOTO et al.**

Art Unit: **1795**

Application Number: **10/647,247**

Examiner: **Daborah Chacko Davis**

Filed: **August 26, 2003**

Confirmation Number: **1773**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND  
METHOD OF FORMING RESIST PATTERN**

Attorney Docket Number: **031029**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.114**

**Mail Stop: RCE**

Commissioner for Patents

April 9, 2009

P. O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Amendment is being filed concurrently with a Request for Continued Examination pursuant to 37 C.F.R. §1.114 and is also being filed in response to the Final Office Action dated December 11, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.